


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

U.S. Serial No. 10/743,629) I hereby certify that this paper (and/or fee)
Applicant: Ki Min LEE) is being deposited with the United States
Filed: December 22, 2003) Postal Service as first class mail in an
Title: "Methods of Preventing) envelope addressed to:
Oxidation of Barrier Metal of) Mail Stop Amendment
Semiconductor Devices") Commissioner for Patents
TC/AU: 2818) P.O. Box 1450
Examiner: NHU, David) Alexandria, VA 22313-1450
Docket No.: 20063/OG03-040) on this date:
)
) Dated: June 6, 2005
)
) 
) Mark C. Zimmerman
) Registration No. 44,006
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO THE OFFICE ACTION DATED MARCH 3, 2005

Dear Sir:

Please enter the following amendments and consider the following remarks.

Changes to the Specification begin on page 2 of this paper.

The Status of the Claims is reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 5 of this paper.